



Application No. 10/813,439  
SEC.1140  
AMENDMENT AFTER FINAL  
November 14, 2006

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent application of : **Mail Stop AF**  
Sung-Sok Choi : **Group Art Unit 1763**  
Serial No. 10/813,439 : **Examiner Zervigon, Rudy**  
Filed March 31, 2004 :

*Please enter w/POE  
dated 1-8-07  
hinda 1-18-07*

**Title: APPARATUS AND SYSTEM FOR, AND METHOD OF SUPPLYING PROCESS GAS IN  
SEMICONDUCTOR DEVICE MANUFACTURING EQUIPMENT**

**AMENDMENT AFTER FINAL**

**U.S. Patent and Trademark Office  
Customer Window, Mail Stop AF  
Randolph Building  
401 Dulany Street  
Alexandria, VA 22314**

**Sir:**

**In response to the Office Action dated August 14, 2006, the following  
amendments and remarks are submitted:**

**Amendments to the Claims are reflected in the Listing of Claims which  
begins on page 2 of this paper.**

**Remarks/Arguments begin on page 5 of this paper.**